first and second portions;

a plurality of first openings formed simultaneously in said first insulating film above both said first and second portions;

a plurality of first conductor plugs formed in said first openings in said first insulating film on said first semiconductor regions in said first portion and on said second semiconductor regions in said second portion;

a first conductive strip formed on said first insulating film in said first portion and electrically connected to one of the first semiconductor regions of said MISFET through one of said first conductor plugs; and

a second conductive strip formed on said first insulating film in said second portion and electrically connected to said second semiconductor regions through said first conductor plugs to electrically connect said second semiconductor regions to one another through said second conductive strip;

a second insulating film formed over said first insulating film and said first and second conductive strips;

a second opening formed in said second insulating film over an upper surface of one of the first conductor plugs formed in one of said first openings in the first insulating film and connected to the other of said first semiconductor regions of said MISFET;

a second conductor plug formed in said second opening in said second insulating film to electrically connect with said one of said first conductor plugs connected to the other of said first semiconductor regions of said MISFET; and

a third conductive strip formed on said second insulating film and electrically connected to said second conductor plug,

wherein one of first conductor plugs is directly physically connected to one of

the first semiconductor regions and the first conductive strip in said first portion and another of the first conductor plugs is directly physically connected to one of the second semiconductor regions and the second conductive strip in the second portion.

47. (Amended) A semiconductor integrated circuit device having a first portion for a memory array and a second portion for a circuit other than the memory array on a semiconductor substrate comprising:

a MISFET arranged in said first portion, said MISFET having first semiconductor regions of n-type conductivity and a gate electrode between said first semiconductor regions;

a second semiconductor region of n-type conductivity and a third semiconductor region of p-type conductivity arranged in said second portion;

a first insulating film formed over said semiconductor substrate to cover said first and second portions;

a plurality of first openings formed simultaneously in said first insulating film above both said first and second portions;

a plurality of first conductor plugs each comprising a tungsten film formed in said first openings in said first insulating film on said first semiconductor regions in said first portion and on said second semiconductor regions in said second portion;

a first conductive strip formed on said first insulating film in said first portion and electrically connected to one of the first semiconductor regions of said MISFET through one of said first conductor plugs; and

a second conductive strip formed on said first insulating film in said second portion and electrically connected to said second and third semiconductor regions